



ELECTRONIC COPY

LG776681006
Report verification at igi.org



February 24, 2026

IGI Report Number **LG776681006**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **CUT CORNERED
RECTANGULAR MODIFIED
BRILLIANT**

Measurements **10.78 X 7.93 X 5.41 MM**

GRADING RESULTS

Carat Weight **4.04 CARATS**

Color Grade **E**

Clarity Grade **VS 1**

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ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

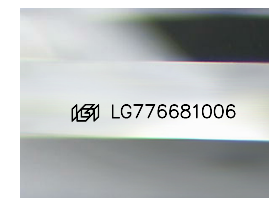
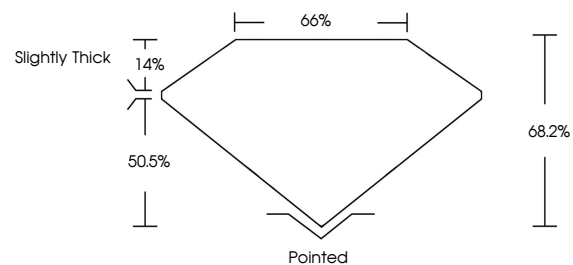
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG776681006**

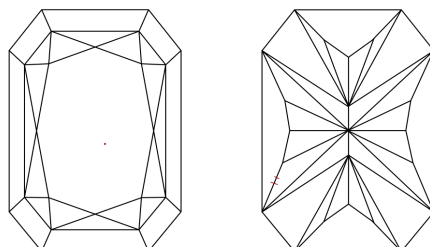
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

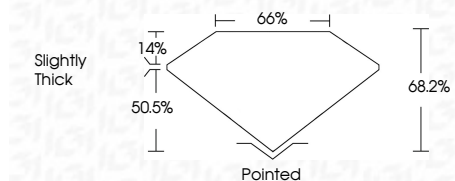
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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IGI



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IGI Report No LG776681006
CUT CORNERED RECT. MODIFIED BRILLIANT
10.78 X 7.93 X 5.41 MM
4.04 CARATS
E
VS 1
68.2%
50.5%
Slightly Thick
Pointed
EXCELLENT
EXCELLENT
NONE
IGI LG776681006
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa